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PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Masamoto TAGO et al.

Conf. No. 9072

Serial No. 09/613,331

GROUP 2818

Filed July 7, 2000

Examiner Q. Hoang

SYSTEM SEMICONDUCTOR DEVICE AND  
METHOD OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

Washington, D.C. 20231

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying documents, copies of which are attached to this statement, are made of record on the enclosed sheet.

A concise explanation of the relevance of these items is that these references were cited by the Japanese Patent Office in an Office Action, a copy of which is attached hereto. An English translation of the portion enclosed in a wavy line is also attached hereto for the Examiner's convenience.

Respectfully submitted,

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